INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 10, 2026

IGI Report Number	LG826684574
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL MIXED CUT
Measurements	11.39 X 7.71 X 5.09 MM

GRADING RESULTS

Carat Weight	3.17 CARATS
Color Grade	E
Clarity Grade	VVS 2

ADDITIONAL GRADING INFORMATION

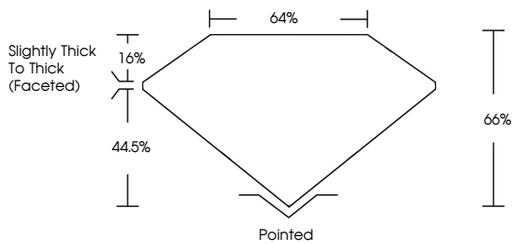
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG826684574

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG826684574

Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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Carat Weight	3.17 CARATS
Color Grade	E
Clarity Grade	VVS 2

64%
Slightly Thick To Thick (Faceted)
16%
44.5%
66%
Pointed

ADDITIONAL GRADING INFORMATION

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Symmetry	EXCELLENT
Fluorescence	NONE
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August 10, 2026
IGI Report No LG826684574
OVAL MIXED CUT
11.39 X 7.71 X 5.09 MM
Carat Weight 3.17 CARATS
Color Grade E
Clarity Grade VVS 2
Depth 65%
Table 64%
Girdle Slightly Thick To Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG826684574
Comments:
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